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Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)		Docket Number (Optional) 3375.6US (95-0999.4)		Application Number Not yet assigned	
		Applicant Donald L. Yates			
		Filing Date December 19, 2001		Group Art Unit Unknown	

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DU	4,132,567	01/1979	Blackwood	1	1	
	4,197,000	04/1980	Blackwood			
	4,286,541	09/1981	Blackwood			
	4,635,666	01/1987	Daley et al.			
	4,682,615	07/1987	Burkman et al.			
	4,911,761	03/1990	McConnell et al.			
	4,984,597	01/1991	McConnell et al.			
	4,997,490	03/1991	Vetter et al.			
	5,069,235	12/1991	Vetter et al.			
	5,095,927	03/1992	Thompson et al.			
DU	5,115,576	05/1992	Roberson, Jr. et al.			

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
DU	0,385,536	05/1990	EP	1	1		
	61-154130	07/1986	Japan				
	4-99025	03/1992	Japan				
	4-152525	05/1992	Japan				
DU	4-253332	09/1992	Japan				

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
DU		Handbook of Semiconductor Wafer Cleaning Technology, editor W. Kern, Noyes Publications, pp. 131-51 and 405-15.
DU		Koppenbrink et al., Particle Reduction on Silicon Wafers as a Result of Isopropyl Alcohol Vapor Displacement Drying after Wet Processing, Particles on Surfaces 2, editor K. Mittal, Plenum Press. pp. 235-43.
DU		Marra et al., Physical Principles of Marangoni Drying, Langmuir, Vol. 7, No. 11, pp. 2748-55.

EXAMINER	H. MARCOW	DATE CONSIDERED	3/10/04
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

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U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JLL	5,186,192	02/1993	Netsu et al.	1	1	
	5,328,867	07/1994	Chien et al.			
	5,520,744	05/1996	Fujikawa et al.			
	5,660,642	08/1997	Britten			
	5,681,397	10/1997	Li			
	5,752,532	05/1998	Schwenkler			
	5,934,299	08/1999	Akatsu et al.			
	5,951,779	09/1999	Koyanagi et al.			
	5,958,146	09/1999	Mohindra et al.			
	6,125,863	10/2000	Bexten			
AK	6,138,690	10/2000	Nakatani			

FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
JLL	4-354128	12/1992	Japan	1	1		
	5-47734	02/1993	Japan				

OTHER DOCUMENTS		(Including Author, Title, Date, Pertinent Pages, Etc.)
AK		Leenaars et al., Marangoni Drying: A New Extremely Clean Drying Process, Langmuir, Vol. 6, No. 11, pp. 1701-03.

EXAMINER	A. MARUO	DATE CONSIDERED	3/10/04
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